

PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Louis N. Koppel et al.

Application No.: NEW

Filed: HEREWITH

For: CALIBRATION AND ALIGNMENT  
OF X-RAY REFLECTOMETRIC  
SYSTEMS .

Group Art Unit: 0

Examiner: Unknown

**PRELIMINARY AMENDMENT**

121 Spear Street, Suite 290  
San Francisco, CA 94105  
(415) 512-1312

M/S PATENT APPLICATION  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Prior to examining the above-identified divisional application, please amend the application as follows:

**Amendments to the Specification** begin on page 2 of this paper.

**Amendment to the Claims** are reflected in the listing of claims which begins on page 3 of this paper.

**Remarks** begin on page 6 of this paper.

Atty Docket No.: TWI-11720